



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masaaki KURIHARA et al.

Serial No.: 10/614,345

Filed: July 8, 2003

For: PHASE MASK FOR FORMING DIFFRACTION GRATING,
METHOD OF FABRICATING PHASE MASK AND METHOD
FOR FORMING DIFFRACTION GRATING

SUBMISSION OF ORIGINAL EXECUTED APPLICATION

Mail Stop Missing Parts
Commissioner for Patents
Box Missing Parts
Washington, D. C. 20231

PLEASE ACCEPT THIS AS
AUTHORIZATION TO DEBIT
OR CREDIT FEES TO
DEP ACCT. 16-0331
PARKHURST & WENDEL

Sir:

The above identified application was duly filed on July 8, 2003, in the Japanese language. Accordingly, submitted herewith is a Verified English-language Translation of the application. Also, submitted herewith is a fully executed Declaration and Assignment of the inventors. Attached is our check for \$1,328.00, which includes \$130.00 to cover the payment of the fee in accordance with 37 CFR 1.17(i), \$130.00 to cover the payment of the fee in accordance with 37 CFR 1.16(e), \$40.00 to cover the fee for recordation of the Assignment document, and the remainder

10/30/2003 MGBREM1 00000075 10614345

01 FC:1001	770.00 OP
02 FC:1201	258.00 OP
03 FC:1051	130.00 OP
04 FC:1053	130.00 OP

to cover the full filing fees.

Entry of these documents should complete all of the filing formalities. Accordingly, examination and allowance of the application in due course are respectfully solicited.

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 160331.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.



Charles A. Wendel

Registration No. 24,453

October 29, 2003

Date

RWP:klb

Attorney Docket No. DAIN:740

PARKHURST & WENDEL, L.L.P.
1421 Prince Street, Suite 210
Alexandria, Virginia 22314-2805
Telephone: (703) 739-0220

(rev. 1/03)